

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Naoki YAMAMOTO
Serial No.: Not yet assigned
Divisional Application of Serial No. 09/639,306, Issued as
Patent No. 6,645,799
Filed: Even date herewith
For: **METHOD OF MANUFACTURING A DUAL GATE
SEMICONDUCTOR DEVICE WITH A POLY-METAL
ELECTRODE (As Amended)**
Group: 2813 (expected)
Examiner: Jack S. J. Chen (expected)

CLAIM FOR PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 27, 2004

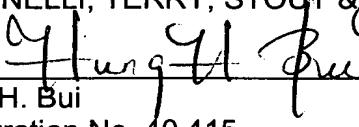
Sir:

Pursuant to 35 U.S.C. §119 and 37 CFR 1.55, the applicants hereby claim the right of priority based on the following foreign applications filed in Japan:

Application No. 2000-017875 filed on January 24, 2000.

A certified copy of this foreign application was filed on September 27, 2000, in application Serial No. 09/639,306, the parent application of the present divisional application.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP


Hung H. Bui
Registration No. 40,415

HHB:btd
(703) 312-6600